Title: METHOD FOR EVALUATING PIEZOELECTRIC FIELDS Inventors: TAKEUCHI et al.

Inventors: TAKEUCHI et al.
Atty Docket No.: 402961

Leydig, Voit & Mayer 202-737-6770

Fig. 1

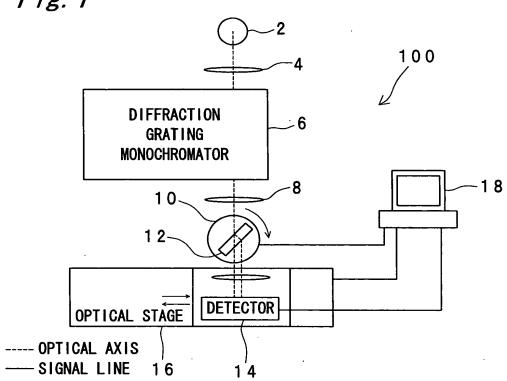
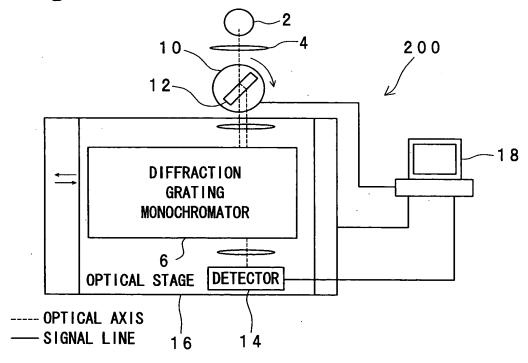
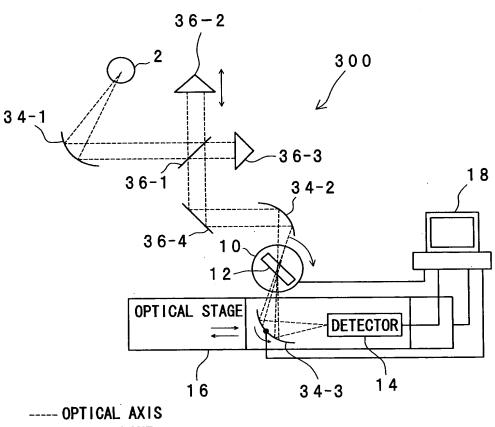


Fig. 2



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Fig. 3

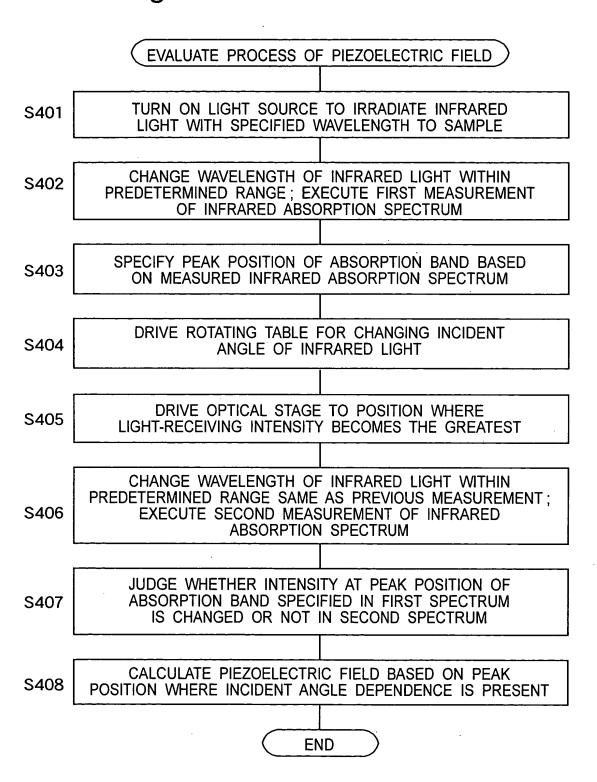


-SIGNAL LINE

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Fig.4



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Fig. 5

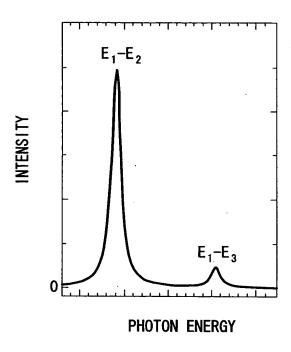
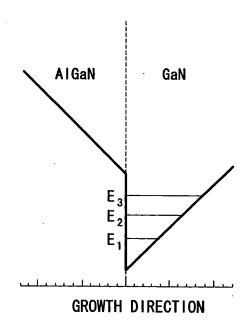


Fig. 6



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Fig. 7

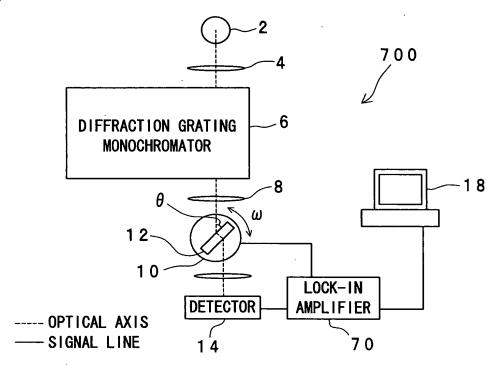


Fig. 8

